## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yoshihisa IBA

Serial Number: Not Yet Assigned

Filed: February 24, 2004 Customer No.: 38834

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

#### INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

February 24, 2004

Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted, WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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Enclosures: PTO-1449; References (4)

INFORMATION DISCLOSURE STATEMENT PTO-1449

Attv. Docket No. 042139	Serial No. New Appln.
Applicant(s): Yoshihisa IBA	
Filing Date: February 24, 2004	Group Art Unit:

## **U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD			-			

# FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
AE	2003-124189	04/25/03	Japan	Abstract & Discussed in the Spec.
AF	3250518	11/16/01	Japan	Abstract & Discussed in the Spec.
AG	3365554	11/01/02	Japan	Abstract & Discussed in the Spec.
AH	2002-026121	01/25/02	Japan	Abstract & Discussed in the Spec.
AI				

## **OTHER DOCUMENTS**

	AJ AK	
Examiner		Date Considered